

PATENT ASSIGNMENT

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NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENCE
CONVEYING PARTY DATA	
Name	Execution Date
Renssalaer Polytechnic Institute	04/25/2007
RECEIVING PARTY DATA	
Name:	National Science Foundation
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State/Country:	VIRGINIA
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Property Type	Number
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PATENT
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Rensselaer

Office of Technology
Commercialization

License to the United States Government

Invention Title: Edge Illumination Photovoltaic Devices and Methods of Making Same

Inventors: Partha S. Dutta

U.S. Filing Date: 07/27/2006

Application Serial No.: 11/493,921

Grant/Contract Number(s): NSF - 0093706

RPI Institution No.: 1002

The invention identified above is Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14, FAR 52.227-11 or FAR 52.227-12 (if applicable) which are included among the terms of the above identified grant or contract award from the United States Government. This document is confirmatory of:

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2. All other rights acquired by the Government by reason of the above identified grant/contract award and the laws and regulations that are applicable to the award.

The government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

Signed this day of April 25, 2007.

By: Charles F. Rancourt

Director, Office of Technology Commercialization

For: Rensselaer Polytechnic Institute

At: Rensselaer Polytechnic Institute - 110 8th Street - Office of Technology Commercialization
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